

[T-08]

The Er³⁺ photoluminescence properties in Er-doped nc-Si/SiO₂ superlattices formed by ion sputtering

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Er-doping of Si has been studied intensely in hopes of developing Si-based optoelectronic devices. Despite the large advances, the Er³⁺ luminescence efficiency achieved is still rather low to realize the devices operating at room temperature. Recently, silicon rich silicon oxide(SRSO), which consisted of Si nanocrystals(nc-Si) embedded in SiO₂ matrix¹⁻³, appears as one of promising candidate for host material and by using SRSO, it is possible to obtain both the high excitation efficiency of Si and the high luminescence efficiency of SiO₂. Unfortunately, the size and density of nc-Si and the location of Er atoms, which are key parameters for obtaining efficient Er³⁺ luminescence, are difficult to control in SRSO. However, such parameters can be easily controlled in SiO_x(x<2)/ SiO₂ superlattice.

In this work, the effects of Si nanocluster on the Er³⁺ photoluminescence properties of Er-doped nc-Si/SiO₂ superlattices⁴⁻⁶ were investigated. The Er-doped SiO_x/SiO₂ superlattice films were deposited by UHV-ion beam sputtering method and were subsequently annealed at 950 or 1100 C. After annealing, Er atoms were well confined in SiO₂ layers whose thickness was fixed at 8 nm. The formation of nc-Si was observed in the films annealed at 1100 C. The size of nc-Si was controlled through the variation of oxygen content(x) and determined by high-resolution transmission electron microscopy(HRTEM). We observed the intense Er³⁺ photoluminescence from Er-doped nc-Si/SiO₂ superlattices and more detailed discussion about the Er³⁺ photoluminescence properties will be presented.

[References]

- I. A. J. kenyon, P. F. Trwoga, M. Federighi, and C. W. Pitt, J. Phys. : Condense. Matter 6, L319 (1994)

2. M. Fujii, M. Yoshida, Y. Kanazawa, S. Hayashi, and K. Yamamoto, Appl. Phys. Lett. 71, 1198 (1997).
3. J. H. Shin, M. J. Kim, S. Y. Seo, and C. C. Lee Appl. Phys. Lett. 72, 1092(1998).
4. J. H. Shin, W. H. Lee, and H. S. Han, Appl. Phys. Lett. 74, 1573(1999).
5. J. H. Shin, J. H. Jhe, S. Y. Seo, Y. H. Ha, D. W. Moon, Appl. Phys. Lett. 76, 3567(2000).
6. Y. H. Ha, S. H. Kim, D. W. Moon, J. H. Jhe, and J. H. Shin, Appl. Phys. Lett. 79, 287(2001).